

JPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of Aiden Flanagan

Group Art Unit: 1752

Application No.: 10/782,073

Examiner: Unassigned

Filed: February 18, 2004

Docket No.: 12013/50801

For LASER-INDUCED EXPLOSIVE VAPORIZATION COATING METHOD,
ASSOCIATED SYSTEM, AND DEVICE MADE BY THE METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR § 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b). The paragraphs marked below are applicable. It is believed that no fees other than those indicated below are due, but authorization is hereby given to charge any additional fees due, or to credit any overpayment, to deposit account 11-0600.

■ 1. This Information Disclosure Statement is being filed (a) within three months of the filing date of a national application other than a continued prosecution application under 37 C.F.R. §1.53(d), (b) within three months of the date of entry of the national stage as set forth in 37 C.F.R. § 1.491 in an international application, (c) before the mailing date of a first Office Action on the merits in the present application, OR (d) before the mailing of a first office action after filing of a request for continued examination. No certification or fee is required.

☐ 2. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a final action, Notice of Allowance, or any action that otherwise closes prosecution.

☐ a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(1).

☐ b. I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(2).

☐ c. Please debit Deposit Account No. 11-0600 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p) to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached. 37 CFR §1.97(c)(2).

☐ 3. This Information Disclosure Statement is being filed after the mailing date of a final action, Notice of Allowance or an action that otherwise closes prosecution, but before payment of the Issue Fee. Applicant(s) hereby request(s) that the Information Disclosure Statement be considered. Please debit Deposit Account No. 11-0600 in the amount of \$180.00 in payment of the petition fee under 37 CFR §1.17(p) to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.

☐ a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(1).

☐ b. I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(2).

☐ 4. Relevance of the non-English language reference(s) is discussed in the present specification.

■ 5. Some or all of the reference(s) was/were cited in a counterpart application (PCT/US2005/004472). Copies of the International Search Report dated June 17, 2005, and the Written Opinion of the International Searching Authority also dated June 17, 2005, are attached for the Examiner's information.

☐ 6. A concise explanation of the relevance of the non-English language reference(s) appears in the Appendix attached hereto.

■ 7. The Examiner's attention is directed to co-pending U.S. Patent Applications 10/782,056 filed February 18, 2004 and 10/789,606 filed February 27, 2004, which are directed to related technical subject matter. The identification of these U.S. Patent Applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination of the present application.

☐ 8. This application is one of a series of related applications, identified in the attached Appendix, which are directed to related technical subject matter. The identification of those U.S. Patent Applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited applications and the art cited therein during the examination.

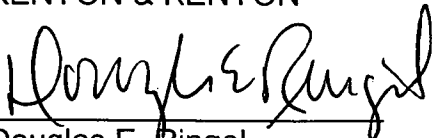
☐ 9. The reference(s) was/were cited by or submitted to the Office in parent application No. _____, filed _____, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

☐ 10. English-language Abstracts of the non-English language references are attached hereto.

☐ 11. Other.

Respectfully submitted,

KENYON & KENYON


Douglas E. Ringel
Registration No. 34,416

Date: 13 July 2005

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Substitute for form 1449A/PTO

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| Sheet | 1 | of | 2 |
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|-------------------------------|-------------------|
| <i>Application Number</i> | 10/782,073 |
| <i>Filing Date</i> | February 18, 2004 |
| <i>First Named Inventor</i> | Aiden Flanagan |
| <i>Art Unit</i> | 1752 |
| <i>Examiner Name</i> | Unassigned |
| <i>Attorney Docket Number</i> | 12013/50801 |

[illegible][illegible]Date
Considered

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.S./

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| Substitute for form 1449B/PTO | | Complete if Known | |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT | | Application Number | 10/782,073 |
| | | Filing Date | February 18, 2004 |
| | | First Named Inventor | Aiden Flanagan |
| | | Art Unit | 1752 |
| | | Examiner Name | Unassigned |
| (Use as many sheets as necessary) | | Attorney Docket Number | 12013/50801 |
| Sheet | 2 | of | 2 |

| NON PATENT LITERATURE DOCUMENTS | | | |
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| Examiner Initials * | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
| | | Reingeisen et al., "Generation of mesoscopic patterns of viable Escherichia coli by ambient laser transfer," Biomaterials 23 (2002), pages 161-166. | |
| | | DORIS V. STEVANOVIĆ ET AL., "Sputtering of frozen Xenon by KeV heavy ions", Nuclear Instruments and Methods in Physics Research Section B: Beam Interactions with Materials and Atoms, February 1984, pages 315-320, Vol. 1, No. 2-3. & STEVANOVIĆ D. V. ET AL., "Sputtering of frozen xenon by keV heavy ions", The Institution of Electrical Engineers, Stevenage, GB; February 1984 (1984-02). & "Nuclear Instruments & Methods in Physics Research, Section B (Beam Interactions with Materials and Atoms)" Netherlands, Proceedings of the 2 nd International Conference on Radiation Effects in Insulators 30 May-3 June 1983, Albuquerque, NM, Vol. 229, No. 2-3. | |
| | | BORING J.W. ET AL., "Sputtering of Solid SO ₂ ", Nuclear Instruments and Methods in Physics Research Section B: Beam Interactions with Materials and Atoms, February 1984, pages 321-326, Vol. 1, No. 2-3. & BORING J. W., ET AL., "Sputtering of solid SO ₂ ", The Institution of Electrical Engineers, Stevenage, GB, February 1984 (1984-02). & "Nuclear Instruments and Methods in Physics Research, Section B (Beam Interactions with Materials and Atoms)" Netherlands, Proceedings of the 2 nd International Conference on Radiation Effects in Insulators 30 May-3 June 1983, Albuquerque, NM, Vol. 229, No. 2-3. | |
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| Examiner Signature | /Cachet Sellman/ | Date Considered | 04/23/2008 |
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.S./